



REISSUE PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Broadening Reissue Application of

Osamu TANITSU et al.

Group Art Unit: 2851

Application No.: 09/326,214

Examiner: A. Mathews

Filed: June 3, 1999

Docket No.: 103512.99

For: ILLUMINATION OPTICAL APPARATUS AND SCANNING EXPOSURE
APPARATUS

AMENDMENT FILED IN REISSUE APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the August 17, 2004 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

IN THE CLAIMS:

Please replace claims 54, 56-58, 78 and 80 with the following amended claims:

54. (Twice Amended) A scanning exposure apparatus comprising:
an illumination optical system arranged to illuminate a slit area on a
predetermined plane on which a mask is arranged, with an illumination beam, an optical axis
of said illumination optical system being substantially perpendicular to said slit area, and said
illumination optical system comprising a fly-eye type integrator having a plurality of optical
elements each of which has a cross sectional shape that is substantially equal to said slit area